

Claim 1 (Currently Amended): A method for operating a non-volatile dynamic random access memory (NVDRAM) device including a plurality of memory cells, each cell having a capacitor and a transistor having a floating gate, comprising:

preparing a power-on mode for performing a DRAM operation by controlling a threshold voltage of the transistor; and

preparing a power-off mode for storing a data included in the capacitor into the floating gate,

wherein the preparing the power-on mode includes:

moving the data stored in the floating gate into the capacitor; and

backing up the stored data in the capacitor before the controlling the threshold voltage of the transistor.

Claims 2-3 (Canceled)

Claim 4 (Currently Amended): The method as recited in <u>claim 2 claim 1</u>, wherein the moving the data includes:

charging the capacitors of all memory cells with a logic HIGH datum; and

discharging the capacitor in the memory cell having the transistor, its floating gate storing a logic high datum.

Claim 5 (Currently Amended): The method as recited in claim 4, wherein the step moving the data includes refreshing the plurality of capacitors.

Claim 6 (Previously Presented): The method as recited in claim 5, wherein the plurality of the memory cells are arranged in a matrix by using a number of word lines and bit lines and the moving the data is carried out in a row-by-row basis.

Claim 7 (Previously Presented): The method as recited in claim 6, wherein the charging the capacitors includes:

supplying one word line connected to a multiplicity of the memory cells with a first threshold voltage in order to turn on the transistors in all of the memory cells;

writing the logic HIGH datum in the capacitors of the memory cells coupled to the word line; and

repeating the charging the capacitors and discharging the capacitor in the memory cell having the transistor until all of the capacitors in the plurality of the memory cells are charged with the logic HIGH datum.

Claim 8 (Previously Presented): The method as recited in claim 4, wherein the discharging the capacitor in the memory cell having the transistor includes:

supplying all of the word lines with a second threshold voltage in order to turn on the transistors, its floating gate storing the logic HIGH datum; and

supplying all of the bit lines with about 0 V in order to discharge the capacitors in the memory cell having the transistor, its floating gate storing the logic HIGH datum.

Claim 9 (Currently Amended): The method as recited in elaim 2 claim 1, wherein the adjusting controlling the threshold voltage includes:

supplying all gates of the transistors in all of the memory cells with a first predetermined voltage in order for fulfilling electrons in the floating gate;

charging all of the capacitors in all of the memory cells; and decreasing the threshold voltage of the transistors to the first threshold voltage.

Claim 10 (Currently Amended): The method as recited in claim 9, wherein the adjusting controlling the threshold voltage including includes:

backing up the captured data in the capacitor before the supplying all gates; and restoring the backup data in the capacitor after the decreasing the threshold voltage.

Claim 11 (Previously Presented): The method as recited in claim 10, wherein the charging all of the capacitors includes:

supplying one side of the capacitor with about 0 V; and supplying the bit line with the logic HIGH datum.

Claim 12 (Previously Presented): The method as recited in claim 11, wherein the decreasing the threshold voltage includes:

removing electrons in the floating gate of the memory cells;

discharging the capacitor by supplying the gate of the transistor in the memory cells with the first threshold voltage; and

repeating the removing electrons and discharging the capacitor by supplying the gate until all of the capacitors are discharged.

Claim 13 (Previously Presented): The method as recited in claim 12, wherein the removing electrons includes:

supplying a gate of the transistor in all of the memory cells with a negative voltage; supplying a plate of the capacitor in the memory cells with voltage level of a logic HIGH datum; and

moving electrons in the floating gate to the capacitor storing the logic HIGH datum.

Claim 14 (Previously Presented): The method as recited in claim 13, wherein the moving electrons in the floating gate includes:

supplying the gate of the transistor with a second threshold voltage; and discharging the capacitor in some of the memory cells having the transistor turned on by the second threshold voltage.

Claim 15 (Currently Amended): The method as recited in claim 14, wherein the adjusting controlling the threshold voltage includes the refreshing all of the memory cells.

Claim 16 (Previously Presented): The method as recited in claim 15, wherein the plurality of the memory cells are arranged in a matrix by using a number of word lines and bit lines and the adjusting the threshold voltage is carried out in a row-by-row basis.

Claim 17 (Original): The method as recited in claim 13, wherein the capacitor is a coupling capacitor.

Claim 18 (Currently Amended): The method as recited in claim 1, wherein the preparing the power-off includes:

removing electrons in the floating gate of the memory cell storing a logic HIGH datum;

discharging the capacitor by supplying gate of the transistor in all of the memory cells with a second threshold voltage; and

repeating the removing electrons in the floating gate of the memory cell storing a logic HIGH datum and removing electrons in the floating gate of the memory cell storing a logic HIGH datum-discharging the capacitor by supplying a gate of the transistor in all the memory cells with a second threshold voltage until all of the capacitors are discharged.

Claim 19 (Currently Amended): The method as recited in claim 18, wherein the removing electrons in the floating gate of the memory cell storing a logic HIGH datum includes the steps of:

supplying a gate of the transistor in all of the memory cells with a negative voltage; supplying a plate of the capacitor in the memory cells with voltage level of a logic HIGH datum; and

selectively moving electrons in the floating gate to the capacitor storing the logic HIGH datum.

Claim 20 (Previously Presented): The method as recited in claim 18, wherein the discharging the capacitor by supplying gate of the transistor in all of the memory cells with a second threshold voltage includes:

supplying the gate of the transistor with a second threshold voltage; and

discharging the capacitor in some of the memory cells having the transistor turned on by the second threshold voltage.

Claim 21 (Previously Presented): The method as recited in claim 20, wherein the discharging the capacitor by supplying gate of the transistor in all of the memory cells with a second threshold voltage includes refreshing the memory cell.

Claim 22 (Previously Presented): The method as recited in claim 21, wherein the discharging the capacitor by supplying gate of the transistor in all of the memory cells with a second threshold voltage is carried out row-by-row.

Claim 23 (Original): The method as recited in claim 19, wherein the capacitor is a coupling capacitor.

Claim 24 (Currently Amended): The method as recited in <u>claim 2 claim 1</u>, wherein the moving the data further includes:

supplying a word line with a voltage defined by the following equation:

$$V_{wl} = V_{blp} + (V_{th-H} + V_{th-L})/2$$

where V_{blp} is a bit line precharge voltage, $V_{\text{th-H}}$ is a first threshold voltage, and $V_{\text{th-L}}$ is a second threshold voltage; and

writing logic HIGH or LOW data in the capacitor in response to whether the threshold voltage is the $V_{\text{th-H}}$ or the $V_{\text{th-L}}$.

Claim 25 (Currently Amended): The method as recited in claim 23 claim 24, wherein the step-moving the data includes refreshing the plurality of memory cells by supplying each word line with a voltage level being higher than the logic HIGH datum.

Claim 26 (Previously Presented): The method as recited in claim 25, wherein the moving the data is carried out row-by-row.

Claim 27 (Currently Amended): The method as recited in claim 26, wherein the supplying a word line further includes supplying other word lines with a predetermined negative voltage except for the word line supplied with the $\frac{V_{wl}^2}{V_{wl}^2}$.

Claim 28 (Currently Amended): A non-volatile dynamic random access memory (NVDRAM) device including a plurality of memory cells in a matrix, each memory cell comprising:

a capacitor for storing a data; and

a transistor for transmitting the data stored in the capacitor to a bit line, wherein the transistor includes a drain, a source, and a gate having a control gate and a floating gate for storing the data when a power is off and a threshold voltage of the transistor is controlled when the power is on,

wherein one terminal of the capacitor is coupled to the drain of the transistor and the another terminal of the capacitor is supplied with a controllable voltage determined according to an operation mode, and when preparing for power-on mode the data stored in the transistor is moved to the capacitor and captured data in the capacitor is backed up before the threshold voltage of the transistor is controlled.

Claim 29 (Previously Presented): The NVDRAM device recited in claim 28, wherein the floating gate of the transistor is made of nitride.

Claim 30 (Previously Presented) The NVDRAM device recited in claim 29, wherein the floating gate of the transistor formed in a single layer serves as a data storage.

Claim 31 (Currently Amended): A non-volatile dynamic random access memory (NVDRAM) including a plurality of memory cells in a matrix, wherein each memory cell includes:

a control gate layer coupled to a word line;

a capacitor for storing data; and

Page 9

a floating transistor for transmitting the stored data in the capacitor to a bit line and storing the data therein in response to an operation mode, wherein, a threshold voltage of the floating transistor is controlled when preparing for the power-on mode is on, the data stored in the floating transistor is moved to the capacitor and the captured data in the capacitor is backed up before a threshold voltage of the floating transistor is controlled

wherein one terminal of the capacitor is coupled to a drain of the floating transistor and the other terminal of the capacitor is supplied with a controllable voltage determined according to the operation mode.

Claim 32 (Original): The NVDRAM device as recited in claim 31, wherein the control gate layer is made of metal and the gate of the floating transistor is made of nitride.

Claim 33 (Original): The NVDRAM recited in claim 32, wherein the gate of the floating transistor formed in a single layer serves as a data storage.

Claim 34 (New): The NVDRAM recited in claim 32, wherein one terminal of the capacitor is coupled to a drain of the floating transistor and another terminal of the capacitor is supplied with a controllable voltage determined according to the operation mode.